## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of		Docket No: Q76454
Shinji YOKONO, et al.		
Appln. No.: 10/611,961		Group Art Unit: 1792
Confirmation No.: 3574		Examiner: James LIN
Filed: July 3, 2003		
For: METHOD FOR MANUFACTURING PLASMA DISPLAY PANEL, INSPECTION METHOD FOR INSPECTING PHOSPOR LAYER AND INSPECTION APPARATUS FOR INSPECTING PHOSPHOR LAYER		
AMENDMENT UNDER 37 C.F.R. § 1.111		
MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450		
Sir:		
In response to the Office Action dated January 3, 2008, please amend the above-		
identified application as follows on the accompanying pages.		
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